

## LELEC2895

2016-2017

## Design of micro and nanosystems

5.0 credits 30.0 h + 30.0 h 1q

Teacher(s) :	Pardoen Thomas ; Flandre Denis ; Raskin Jean-Pierre ; Francis Laurent (coordinator) ;					
Language :	Anglais					
Place of the course	Louvain-la-Neuve					
Inline resources:	Moodle  > http://moodleucl.uclouvain.be/course/view.php?id=7527					
Main themes :	This cursus is part of the MEMS & mp; NEMS, Micro and Nanotechnology ELEC options. LELEC2895 is focused on the understanding and the design of micro-electromechanical devices (MEMS), on transducers (sensors, actuators) made using micro and nanofabrication technologies, to their co-integration with integrated circuits (IC), to their multiphysics simulation and characterisation, to their reliability and their interconnect.					
Aims:	With respect to the AA referring system defined for the Master in Electrical Engineering, the course contributes to the develoopment, mastery and assessment of the following skills:					
Evaluation methods :	The contribution of this Teaching Unit to the development and command of the skills and learning outcomes of the programme(s) can be accessed at the end of this sheet, in the section entitled "Programmes/courses offering this Teaching Unit".  The project evaluation is based on the style and content of a written report and an oral presentation made by group. The exam					
Teaching methods :	is an open book format.  The course is organised as following 8 sessions of theoretical lectures 3 sessions of exercices 2 tutorial sessions to become acquainted with the software required for the project					
Content :	1. MEMS design methodology 2. Scale effects and transduction principles 3. Sensors and actuators: electrical, mechanical, thermal, optical, (bio)chemical, etc 4. Fabrication processes 5. MEMS and CMOS technology circuits co-integration 6. Interconnections and packaging 7. Multiphysics simulations and characterizations					

## Université Catholique de Louvain - COURSES DESCRIPTION FOR 2016-2017 - LELEC2895

Bibliography:	Supports Slides available on Moodle
	Reference books available at the library BST (Ville Kaajakari, "Practical MEMS", Small Gear Publishing)
Other infos :	LELEC2560 Micro and Nanofabrication Techniques is a desirable prerequisite. Basic knowledge of electronics, solid-state physics, materials science and chemistry is an advantage.
Faculty or entity in charge:	ELEC

Programmes / formations proposant cette unité d'enseignement (UE)							
Intitulé du programme	Sigle	Credits	Prerequis	Acquis d'apprentissage			
Master [120] in Chemical and Materials Engineering	KIMA2M	5	-	•			
Master [120] in Physical Engineering	FYAP2M	5	-	•			
Master [120] in Electrical Engineering	ELEC2M	5	-	0			
Master [120] in Electro- mechanical Engineering	ELME2M	5	-	•			